## GaAs 基板上に異なる温度で成長させた GaSb バルクのスピン緩和

Spin relaxation in bulk GaSb grown at different temperatures on GaAs substrate

<sup>O</sup>田中 大介<sup>1</sup>、Lianhe Li<sup>2</sup>、谷川 詩馬<sup>1</sup>、飯田 真之<sup>1</sup>、滝沢 将也<sup>1</sup>、Edmund Linfield<sup>2</sup>、竹内 淳<sup>1</sup>

(1. 早大先進理工、2. Univ. of Leeds)

°D. Tanaka<sup>1</sup>, L. H. Li<sup>2</sup>, S. Tanigawa<sup>1</sup>, M. Iida<sup>1</sup>, M. Takizawa<sup>1</sup>, E. Linfield<sup>2</sup>, and A. Tackeuchi<sup>1</sup> (1.Waseda Univ., 2. Univ. of Leeds)

## E-mail address: diceke.20@ruri.waseda.jp

GaSb materials grown on GaAs substrates are promising for infrared applications.<sup>1</sup> But a lattice mismatch of ~ 7% exists between GaSb and GaAs.<sup>2</sup> In this study, we have investigated the spin relaxation in GaSb grown on a GaAs substrate at different growth temperatures.

The samples are 1 µm-thick GaSb grown on a GaAs substrate by molecular beam epitaxy. The growth temperatures are 530 °C (sample A), 515 °C (sample B), 510 °C (sample C) and 500 °C (sample D). The spin relaxation process was observed by pump and probe reflection measurement at 10-100 K.<sup>3</sup> A Ti-sapphire laser with an optical parametric oscillator was used as the optical source for the pump and probe experiment. The time resolution in this system is sub-picosecond.

As for the sample A, the time evolution of spin-dependent reflection intensity at 10 K for 40 mW is shown in Figure 1, where  $I^+$  and  $I^-$  indicate the cocircular and anticircular polarization, respectively. The time evolution of spin polarization is shown in the inset of Fig.1. The spin relaxation time  $\tau_{s'}$  which is twice the relaxation time of the spin polarization, is evaluated to be 97.0 ps.

At low temperature, Bir-Aronov-Pikus process<sup>4</sup> is known to be most effective.<sup>5</sup> In Elliott-Yafet (EY) process, spin flips by scattering on impurities or phonons.<sup>6, 7</sup> The obtained spin relaxation times for four samples at 10 K for 40 mW are shown in Fig.2. The spin relaxation time of the sample C is longest in these samples. The observed difference in the spin relaxation times suggests that EY process is also effective.



**Fig.1** Time evolutions of spin-dependent reflection intensity and (inset) spin polarization at 10 K for 40 mW.



**Fig.2** Spin relaxation times of sample A (530°C), sample B (515°C), sample C (510°C) and sample D (500°C) at 10 K for 40 mW.

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